

Electronic Acknowledgement Receipt

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Application Number:	10756122
International Application Number:	
Confirmation Number:	4554
Title of Invention:	Low dielectric constant film produced from silicon compounds comprising silicon-carbon bond
First Named Inventor/Applicant Name:	Wai-Fan Yau
Customer Number:	44257
Filer:	Keith M. Tackett/Teresa Fish
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Application Type:	Utility under 35 USC 111(a)

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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		002592- C7_SIDS_and_Fee_Transmittal. pdf	207222 3af4b60dd1a4c02dd2e44a47e9b67900a6b92a86	yes	5

	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Transmittal Letter		1	2	
	Information Disclosure Statement (IDS) Filed (SB/08)		3	4	
	Fee Worksheet (PTO-875)		5	5	
Warnings:					
Information:					
2	NPL Documents	BOGART-- Plasma_Enhanced_Chemical_Vapor_Deposition.pdf	439305 f6862e0e40e7a9cb76b0df052fb7e363e2515db8	no	6
Warnings:					
Information:					
3	NPL Documents	KLUMP-- Photo_Induced_Transformation_of_Polysiloxane_Layers.pdf	355174 13b05644c1a4c72fbd9a88c4f0ca1eed101a3c91	no	4
Warnings:					
Information:					
4	NPL Documents	BoardDecisionDtd09-16-04.pdf	220285 2603f764f12511f750fcfdca33798ae42f74e72c	no	9
Warnings:					
Information:					
5	NPL Documents	BoardDecisionDtd12-23-04.pdf	195363 f8f8e6877160faf3e1cd5776988ad01f585e843e	no	7
Warnings:					
Information:					
6	NPL Documents	WOLF-- Silicon_Processing_for_the_VLSI_Era.pdf	1381429 584fe16c44e6cdee7636a3ab84541f38b6439c65	no	16
Warnings:					
Information:					
7	NPL Documents	Prosecution_History_for_USSN_11-877483.pdf	1172097 a07a84e7981e4f39084df0544fcf3dda13c7327d	no	26
Warnings:					
Information:					
Total Files Size (in bytes):			3970875		

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.